## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	) : Examiner: Asok K. Sarkar
YUKIKO IWASAKI, ET AL.	) : Group Art Unit: 2829
Application No.: NYA	)
Filed: Concurrently Herewith	; ;
For: METHOD FOR MANUFACTURING A SEMICONDUCTOR FILM	) : ) September 5, 2003
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

## INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. All of the listed documents are filed in the parent application, with the exception of U.S. Patent No.6,448,155, a copy of which is enclosed herewith.

The Examiner's attention is also directed to the following U.S. Application:

APPLICATION NO.	FILING DATE	GROUP ART UNIT
09/346,678	7/2/99	2815

## CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 24,613

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FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)		ATTY DOCKET NO. APPLICATION NO. NYA 03560.002998 Div.						
		APPLICANT YUKIKO IWASAKI, ET AL.	APPLICANT					
	(Use several sheets if neces	ssary)	FILING DATE September 5, 2003		GROUP 2812			
	U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
	5,856,229	1/5/99	Sakaguchi, et al.		406			
	6,054,363	4/25/00	Sakaguchi, et al.		406			
	6,258,702 B1	7/10/01	Nakagawa, et al.		570			
	6,448,155	9/1002	lwasaki, et al.		464			
	6,222,167	04-2001	Wada, et al.	219	645			
	6,274,937	08-2001	Ahn, et al.		777			
	6,486,008	11-2002	Lee		149			
	6,548,382	04-2003	Henley, et al.	438	526			
FOREIGN PATENT DOCUMENTS								
	DOCUMENT NUMBER	DATE	COUNTRY	CLAS	S SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT		
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)								
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DATE CONSIDERED

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**EXAMINER** 

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.